



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 19, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG758574543

LABORATORY GROWN DIAMOND

CUT CORNERED RECTANGULAR  
MODIFIED BRILLIANT

10.33 X 6.90 X 4.74 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

3.07 CARATS

D

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

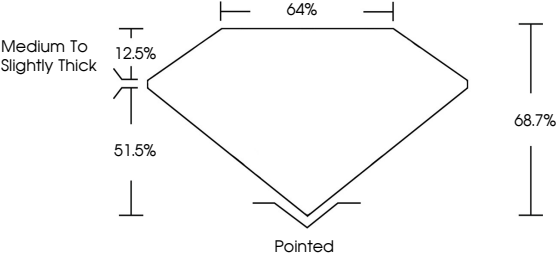
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



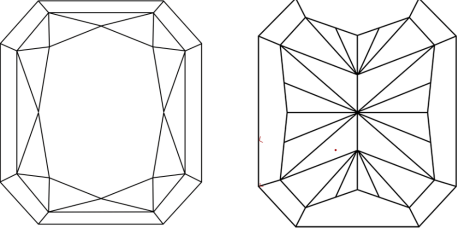
LG758574543

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



December 19, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG758574543

LABORATORY GROWN DIAMOND

CUT CORNERED RECTANGULAR MODIFIED  
BRILLIANT

10.33 X 6.90 X 4.74 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

3.07 CARATS

D

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



LG758574543



IGI

December 19, 2025

IGI Report No LG758574543

CUT CORNERED RECT. MODIFIED BRILLIANT

10.33 X 6.90 X 4.74 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Graile

Medium to Slightly Thick

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

3.07 CARATS

D

VVS 1

68.7%

64%

Pointed

EXCELLENT

EXCELLENT

NONE



Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa